

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hiroyuki SHIBATA et al.

U.S. Patent 7,193,596

Serial No. 09/760,883

Group Art Unit: 2629

Confirmation No. 4981

Filed: January 17, 2001

Examiner: KOVALICK, VINCENT E

For: DISPLAY APPARATUS WITH REDUCED NOISE EMISSION AND DRIVING METHOD
FOR THE DISPLAY APPARATUS

PETITION UNDER 37 CFR 3.81(b)

AND REQUEST FOR CERTIFICATE OF CORRECTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants uncovered, upon further review, that due to an inadvertent error made on the Issue Fee Transmittal filed on February 12, 2007 to pay the Issue and Publication Fees in the subject application, resulted in an error appearing on the face of the Letters Patent; and, unfortunately, was overlooked until now.

When Applicants prepared and filed the Issue Fee Transmittal on February 12, 2007, the Transmittal inadvertently listed HITACHI, LTD. as the sole Assignee and omitted the second Assignee's name of **FUJITSU HITACHI PLASMA DISPLAY LIMITED**.

FUJITSU LIMITED AND FUJITSU HITACHI PLASMA DISPLAY LIMITED has had joint ownership in the subject application since the initial filing date of January 17, 2001. The Assignment was recorded on January 17, 2001 at Reel 011464 and Frame 0046. (Please see the attached PAIR report).

Since, on December 23, 2005 at Reel 017136 and Frame 0874, FUJITSU LIMITED assigned its entire rights to HITACHI LTD. (Please see the attached PAIR report); and, in addition to that, HITACHI LTD., on October 29, 2008 at Reel 021785 and Frame 0276 assigned its entire rights to HITACHI PLASMA PATENT LICENSING CO., LTD., which was filed after the Patent issued. (Please see the attached PAIR report).


Accordingly, Applicants respectfully request that the PETITION and REQUEST FOR CERTIFICATE OF CORRECTION be entered and made of record to correct and add the appropriate Assignee's names of - - **HITACHI, LTD. AND FUJITSU HITACHI PLASMA DISPLAY LIMITED- .**

If there are any additional fees associated with filing of this Petition, please charge the same to our Deposit Account No. 19-3935.

Respectfully submitted,

STAAS & HALSEY LLP

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1872.1005

09/760,883

DISPLAY APPARATUS WITH REDUCED NOISE EMISSION AND DRIVING METHOD FOR THE DISPLAY APPARATUS09-24-
2009::16:04:24**Patent Assignment Abstract of Title****Total Assignments: 3**

Application #: 09760883

Filing Dt: 01/17/2001

Patent #: 7193596

Issue Dt: 03/20/2007

PCT #: NDNE

Publication #: US20010026252

Pub Dt: 10/04/2001

Inventors: Hiroyuki Shibata, Yoshiro Murayasu, Satoshi Watanabe

Title: DISPLAY APPARATUS WITH REDUCED NOISE EMISSION AND DRIVING METHOD FOR THE DISPLAY APPARATUS

Assignment: 1

Reel/Frame: 011464 / 0046

Received: 01/30/2001

Recorded: 01/17/2001

Mailed: 04/09/2001

Pages: 2

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

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Exec Dt: 01/09/2001

Exec Dt: 01/09/2001

Exec Dt: 01/09/2001

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Reel/Frame: 017136 / 0874

Received: 12/23/2005

Recorded: 12/23/2005

Mailed: 02/09/2006

Pages: 3

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

Assignor: FUJITSU LIMITED

Exec Dt: 10/18/2005

Assignee: HITACHI, LTD.

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1201 NEW YORK AVE., N.W., SUITE 700
WASHINGTON, D.C. 20005**Assignment: 3**

Reel/Frame: 021785 / 0276

Received: 11/04/2008

Recorded: 10/29/2008

Mailed: 11/05/2008

Pages: 3

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

Assignor: HITACHI LTD.

Exec Dt: 09/01/2006

Assignee: HITACHI PLASMA PATENT LICENSING CO., LTD.

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Search Results as of: 09/24/2009 16:04:07 PM

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If the assignment for a patent was not recorded, the name of the assignee on the patent application publication or patent may be different.

If you have any comments or questions concerning the data displayed, contact OPR / Assignments at 571-272-3350

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